

IRW



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

application of

Docket No: Q76454

Shinji YOKONO, et al.

Appln. No.: 10/611,961

Group Art Unit: 1762

Confirmation No.: 3574

Examiner: James Lin

Filed: July 3, 2003

For: METHOD FOR MANUFACTURING PLASMA DISPLAY PANEL, INSPECTION
METHOD FOR INSPECTING PHOSPOR LAYER AND INSPECTION APPARATUS
FOR INSPECTING PHOSPHOR LAYER

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated September 11, 2006, please amend the above-
identified application as follows on the accompanying pages.

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